

Marina Krotofil

COINS summer school on Security Applications, Lesbos, Greece (online) 14-18.11.2021



- M. Krotofil "Rocking the Pocket Book: Hacking Chemical Plants for Fun and Profit", Black Hat, USA, 2015
- J. Wetzels, M. Krotofil "A Diet of Poisoned Fruit: Designing Implants and OT Payloads for ICS Embedded Devices", TROOPERS, Germany, 2019

https://www.blackhat.com/docs/us-15/materials/us-15-Krotofil-Rocking-The-Pocket-Book-Hacking-Chemical-Plant-For-Competition-And-Extortion.pdf https://troopers.de/downloads/troopers19/TROOPERS19_NGI_IoT_diet_poisoned_fruit.pdf

Cyber-Physical Attack Development Lifecycle

- If you know how attackers work, you can figure out how to stop them
- Attack lifecycle is a common method to describe a process of conducting cyber attacks



"Stages of SCADA attack", 2007



IND SHOP

J. Larsen. Breakage. Black Hat Federal (2007)

Cyber-Physical Attack Lifecycle



Lockheed Martin, the Cyber Kill Chain®



https://www.lockheedmartin.com/en-us/capabilities/cyber/cyber-kill-chain.html

Mandiant Attack Lifecycle



NUMBER OF

http://www.iacpcybercenter.org/resource-center/what-is-cyber-crime/cyber-attack-lifecycle/

SANS Industrial Control System Cyber Kill Chain

And a second sec

10.00





You are here

ICS MITRE ATT&CK

Initial Access	Execution	Persistence	Privilege Escalation	Evasion	Discovery	Lateral Movement	Collection	Command and Control	Inhibit Response Function	Impair Process Control
Data Historian Compromise	Change Operating Mode	Modify Program	Exploitation for Privilege Escalation	Change Operating Mode	Network Connection Enumeration	Default Credentials	Automated Collection	Commonly Used Port	Activate Firmware Update Mode	Brute Force I/O
Drive-by Compromise	Command-Line Interface	Module Firmware	Hooking	Exploitation for Evasion	Network Sniffing	Exploitation of Remote Services	Data from Information Repositories	Connection Proxy	Alarm Suppression	Modify Parameter
Engineering Workstation	Execution through API	Project File Infection		Indicator Removal on Host	Remote System Discovery	Lateral Tool Transfer	Detect Operating Mode	Standard Application Layer Protocol	Block Command Message	Module Firmware
Compromise	Graphical User Interface	System Firmware	mware	Masquerading	Remote System Information	Program Download	I/O Image		Block Reporting Message	Spoof Reporting Message
Exploit Public-Facing Application	Hooking	Valid Accounts		Rootkit	Discovery	Remote Services	Man in the Middle	1	Block Serial COM	Unauthorized Command Message
Exploitation of Remote Services	Modify Controller Tasking			Spoof Reporting Message	Wireless Sniffing	Valid Accounts	Monitor Process State	1	Data Destruction	Impact
External Remote Services	Native API]	L	Point & Tag Identification	1	Denial of Service	Damage to Property
Internet Accessible Device	Scripting						Program Upload	1	Device Restart/Shutdown	Denial of Control
Remote Services	User Execution						Screen Capture	-	Manipulate I/O Image	Denial of View
Replication Through Removable Media]					Wireless Sniffing	-	Modify Alarm Settings	Loss of Availability
Roque Master	-							-	Rootkit	Loss of Control
Spearphishing Attachment	-								Service Stop	Loss of Productivity and Revenue
Supply Chain Compromise	-								System Firmware	Loss of Protection
Misslass Compromise	-									Loss of Safety
Wireless Compromise										Loss of View
										Manipulation of Control
										Manipulation of View

A bit everywhere :-)

Theft of Operational Information

Why to attack ICS

Industry means big business Big business == \$\$\$\$\$\$



Why to attack ICS

Industry means big business Big business == \$\$\$\$\$\$\$

Alan Paller of SANS (2008):

In the past two years, hackers have in fact successfully penetrated and extorted multiple utility companies that use SCADA systems.

Hundreds of millions of dollars have been extorted, and possibly more. It's difficult to know, because they pay to keep it a secret. This kind of extortion is the biggest untold story of the cybercrime industry.

Attack scenario: Persistent economic damage



What can be done to the process

Equipment damage	Production damage	Compliance violation				
 Equipment overstress Violation of safety limits 	 Product quality and product rate Operating costs Maintenance efforts 	 Safety Pollution Contractual agreements 				

Paracetamol



	Purity	Relative price, EUR/kg							
10. M	98%	1							
	99%	5							
	100%	8205							

Source: http://www.sigmaaldrich.com/



Attack considerations

• Equipment damage

- Comes first into anybody's mind (+)
- Irreversible (\mp)
- Unclear collateral damage (-)
- May transform into compliance violation, e.g. if it kills human (-)

Compliance violation

- Compliance regulations are public knowledge (+)
- Unclear collateral damage (-)
- Must be reported to the authorities (\mp)
- Will be investigated by the responsible agencies (-)



Vinyl Acetate Monomer plant (model)



Plants for sale

From LinkedIn



any interest, please contact me! Tommy Heino

Used VAM - Vinyl Acetate Monomer plant for sale & relocation! If

+Follow Tommy

Industrialist & Entrepreneur, Owner, XHL Business Engineering Top Contributor

Like • Comment (4) • Share • Follow • 3 months ago

More plants offers: http://www.usedplants.com/



Why models?





It is all about MONEY

Plants are ouch! how expensive -> hence, researching on model

Access

- Target facility
 - Discovery
 - Access to needed assets
 - Attack execution
- Trusted 3rd party (staging target)
 - Access to target facility
 - Access to needed assets
 - Process comprehension
- Non-targeted/Opportunistic





- There are few known cases of strategic targeting
- Target might be also selected as best suitable certain criteria
- Collateral victim
- Opportunistic



Ukraine, 2016

- INDUSTROYER malware was deployed to shutdown electricity distribution at Pivnichna substation
- There is <u>no</u> strong <u>indications</u> that victim substation was <u>strategic target</u>
- Details of substation upgrade were publicly available



Ukraine, 2016



OSINT: Tons of confidential info on Internet

8.10.3 Alarm On-Delay and Off-Delay

HYDROGEN PLANT

22 V-108 ABC

22 E-104

1 ST KO DRUM

58,23

22 A-106 P 8 A

HYDROGEN

PURIFICATION UNIT

22 E-108

HYDROGEN

FLARE

40 65,98

(22,1)

The On-Delay alarm attribute is used to avoid unnecessary alarms, by allowing alarms to be triggered once the signal has remained in the alarm state for a specified length of time. The Off-Delay alarm attribute is used to reduce chattering alarms by locking in the alarm indication for a specified period after it has cleared. On-Delay and Off-Delay times should be used after careful evaluation of potential control system operational effects. Table 8 [2] below provides recommended time delays based on signal types.



Attackers C2

-						
ſ	Злоумышленник	176.	.210	-	-	[19/Jan/2016:11:19:32 +0200]
	подготавливает сервер к атаке. Работа ведется	176.	.210	-	-	[19/Jan/2016:12:18:48 +0200]
	через обыкновенный WSO веб-шелл с паролем по умолчанию	176.	.210	-	-	[19/Jan/2016:13:25:49 +0200]
		176.	.210	-	-	[19/Jan/2016:16:36:13 +0200]
	Жертва 1 скачивает бэкдор	82.	.102	-	-	[19/Jan/2016:18:12:41 +0200]
	Жертва 2 скачивает бэкдор	217.	.41	-	-	[19/Jan/2016:18:14:41 +0200]
	Жертва 3 скачивает бэкдор	176.	.22	-	-	[20/Jan/2016:08:42:36 +0200]
	Жертва 4 скачивает бэкдор	194.	.10	-	-	[20/Jan/2016:09:11:38 +0200]
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	Жертва 4 скачивает бэкдор	194.	.10	-	-	[20/Jan/2016.00.44.13 +02001]
	Sandbox скачивает бэкдор	184.	.147	-	-	[20/Jan
	Жертва 6 скачивает бэкдор	82.	.70	-	-	[20/Jan Год Месяц День 8



Infrastructure recon

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Staging targets

Alert (TA18-074A)

Russian Government Cyber Activity Targeting Energy and Other Critical Infrastructure Sectors

Original release date: March 15, 2018 | Last revised: March 16, 2018

This campaign comprises two distinct categories of victims: staging and intended targets. The initial victims are peripheral organizations such as trusted third-party suppliers with less secure networks, referred to as "staging targets" throughout this alert. The threat actors used the staging targets' networks as pivot points and malware repositories when targeting their final intended victims. NCCIC and FBI judge the ultimate objective of the actors is to compromise organizational networks, also referred to as the "intended target."

https://www.us-cert.gov/ncas/alerts/TA18-074A

Bit9

Trojanized ICS Installers **TELVENT** Security Centre

Advisory: Hostile state actors compromising UK organisations with focus on engineering and industrial control companies

The NCSC is aware of an ongoing attack campaign <mark>against multiple companies</mark> involved in the <mark>CNI supply chain</mark>. These attacks have been ongoing since at least March 2017. The targeting is focused on

https://www.ncsc.gov.uk/news/hostile-state-actors-compromisinguk-organisations-focus-engineering-and-industrial-control

Smart instrumentation

Smart instrumentation

- Converts analog signal into digital
- Sensors pre-process the measurements
- May send data directly to actuators
- IP-enabled (part of the "Internet-of-Things")



Promise from the vendors:

Expect instruments of the future to have multiple communication channels, much like a present-day Ethernet switch. These channels will be managed with IP adressing and server technology, allowing the instrument to become a true data server

Complication: Resource constraints



- MPC860, 50 MHz
- 6 MB Flash
- 16 MB DRAM
- 32 KB SRAM



You better enjoy

Will need to fit implant in there Signals processing? Malicious logic? Comms? Often stretched by normal functionality already



- ARM9, 14 MHz
- 512 KB Boot Flash
- 8 MB RW Flash
- 2 MB SRAM



- Network reconnaissance
 - Majority of this stage is similar to traditional IT recon process/attack life cycle, most tools will differ
 - Information enumeration
- Process comprehension
 - Understanding exactly what the process is doing, how it is built, configured & programmed



Comprehension

On the Significance of Process Comprehension for Conducting Targeted ICS Attacks

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http://eprints.lancs.ac.uk/88089/1/sample_sigconf.pdf





http://eprints.lancs.ac.uk/88089/1/sample_sigconf.pdf

Process discovery/comprehension



What and how the process is producing



How it is controlled



How it is build and wired



Operating & safety constraints







Process Discovery



н-о н

1.

H⁺

heat H3C 6

 $+ H_{3}O^{1}$

Know the equipment

Stripper is...



Stripping column



Max economic damage?



Requires input of subject matter experts

Understanding points and control logic

Programmable Logic Controller





Piping and instrumentation diagram

Ladder logic



Pump in the plant

Understanding points and control logic



Piping and instrumentation diagram

Pump in the plant

Understanding control infrastructure

ARGUN


Control loop configuration

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Watch the flows!



HAc flows into two sections. Not good :(

Obtaining Control != Being in control



- Obtained controls might not be useful for attack goal
- How do I even speak to this thing??
- Attacker might not necessary be able to control obtained controls

Huh ???



Every action has a reaction



- Least understood and studied stage among all
- It is about discovering:
 - Dynamic model of the process and its limits
 - Ability to control process
 - Attack effect propagation
 - Active stage in live environment





Physics of process control

- Once connected together, physical components become related to each other by the physics of the process
- If we adjust a valve what happens to everything else?
 - Adjusting temperature also increases pressure and flow
 - All the downstream effects need to be taken into account (upstream changes too)
- How much does the process can be changed before releasing alarms or it shutting down?



Process interdependencies



DOM: D

Process interdependencies



DOM: D

Understanding process responce



Understanding process responce

ARGINE



Process control challenges

• Process dynamic is highly non-linear (???)



- Behavior of the process is known to the extent of its modelling
 - So to controllers. They cannot control the process beyond their control model

UNCERTAINTY!



Control loop ringing





Outcome of the control stage



l am 163 cm tall

Control stage execution needs assistance with specialized tools (none available so far!)

Outcome of the control stage

Sensitivity	Magnitude of manipulation	Recovery time
High	XMV {1;5;7}	XMV {4;7}
Medium	XMV {2;4;6}	XMV {5}
Low	XMV{3}	XMV {1;2;3;6}

Reliably useful controls

Damage

- Requires subject-matter knowledge (engineering)
- Cant take several forms
 - Explosions (of course!)
 - Equipment breakage
 - Pollution
 - Product Out-of-Specification
 - Increased production costs, etc.





Discovery

Access

Obtain

Feedback

Control

Prevent

Response

Cleanup

Damage

https://img.izismile.com/img/img5/20120306/640/chemical_plant_accident_in_germany_640_04.jpg



How do we achieve needed physical impact?

Attacker needs one or more attack scenarios to deploy in final payload

- The least familiar stage to IT hackers
 - In most cases requires input of subject matter experts
- Accident data is a good starting point
 - Governmental agencies
 - Plants' own accident data bases







Hacker unfriendly process

- Attacker need to <u>obtain feedback</u> in order to observe progress of the attack
- Target plant may not have been designed in a hacker friendly way
 - There may no sensors measuring exact values needed for the attack execution
 - The information about the process may be spread across several subsystems forcing attacker to compromise greater number of devices
 - Control loops may be designed to control different parameters that the attacker needs to control for her goal



00

Obtain feedback: Measuring process



Measuring attack success

If you can't measure it, you can't manage it Peter Drucker



Measurement precision

Technician

"It will eventually drain with the lowest holes loosing pressure last"



Engineer

"It will be fully drained in 20.4 seconds & the pressure curve looks like this"

"Technician" answer

Usage of proxy sensor





Reactor with cooling tubes

- Only tells us whether reaction rate increases or decreases
- Is not precise enough to compare effectiveness of different attacks

Quest for engineering answer

- Code in the controller
- **Optimization applications**
- Test process/plant



seem being useful : 0,00073; 0,00016; 0,0007...

Bingo! Engineering answer obtained





Vinyl acetate production



After two weeks of research and calculations, I finally got the numbers (YES!!)

Product loss

Product per day: 96.000\$

Product loss per day: 11.469,70\$



KPI

Prevent responce: Alarm propagation

Alarm	Steady state attacks	Periodic attacks
Gas loop 02	XMV {1}	XMV {1}
Reactor feed T	XMV {6}	XMV {6}
Rector T	XMV{7}	XMV{7}
FEHE effluent	XMV{7}	XMV{7}
Gas loop P	XMV{2;3;6}	XMV{2;3;6}
HAc in decanter	XMV{2;3;7}	XMV{3}

The attacker needs to figure out the marginal attack parameters which (do not) trigger alarms – to prevent response

Outcome of the damage stage

Product per day: 96.000\$

Product loss, 24 hours	Steady-state attacks	Periodic attacks
High, ≥ 10.000\$	XMV {2}	XMV {4;6}
Medium, 5.000\$ - 10.000\$	XMV {6;7}	XMV {5;7}
Low, 2.000\$ - 5.000\$	-	XMV {2}
Negligible, ≤ 2.000\$	XMV {1;3}	XMV {1;2}

Still might be useful



- In traditional (IT systems) hacking the goal is to stay undetected. In cyber-physical exploitation it is not an option because of physical effect:
 - Changes things in physical world which cannot hidden by e.g. "erasing logs"
 - Visible to observers
- Create forensic footprint of:
 - What operators think is currently causing process upset
 - What the investigators should identify as cause of the incident/accident
 - E.g. time attack to specific employee shift or modify attack in response to process troubleshooting





Socio-technical system



Creating forensic footprint

- Process operators may get concerned after noticing persistent decrease in production and may try to fix the problem
 - What do you want operators to think is causing process upset?
- If attacks are timed to a particular employee shift or maintenance work, plant employee will be investigated rather than the process



Creating forensic footprint

- 1. Pick several ways that the temperature can be increased
- 2. Wait for the scheduled instruments calibration
- 3. Perform the first attack
- 4. Wait for the maintenance guy being yelled at and recalibration to be repeated
- 5. Play next attack
- 6. Go to **4**



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Defeating chemical forensics

- If reactor doubted, chemical forensics guys will be asked to assist
- Know metrics and methods of chemical investigators
- Change attack patterns according to debugging efforts of plant personnel







Security is not a fundamental science It is application driven

Security solutions exist in the context of the application

Early adopter: eCommerse

Security influences design decisions

- Attackers (mis)use functionality of web browsers
- Novel approaches to designing web applications
- Novel security controls in browsers

- Application dictates security properties
 - Information-theoretic security properties
 - CIA triad --> Parkerian hexad



Failed to adopt

- Wireless sensor networks: Big hope
 - A big hype for about a decade
 - Conferences, solutions, promising applications
 - Remained a "promising" technology with limited deployment
- Wireless sensor networks: Big flop
 - Deficiencies in the attacker models and security requirements
 - Unrealistic assumptions about physics of wireless communication

D. Gollmann, M. Krotofil, H. Sauff. Rescuing Wireless Sensor Networks Security from Science Fiction (WCNS'11)







SANS: ICS cyber-kill chain



100000

AND DESCRIPTION OF
Designing cyber-physical payload





https://bloximages.newyork1.vip.townnews.com/hannapub.com/content/tncms/assets/v 3/editorial/e/00/e00b6032-b883-11e9-863f-3f8704327902/5d49dabf0e770.image.jpg

Evil Motivation

Cyber-physical Payload

Knoweldge involved into exploit development



Knoweldge involved into exploit development



Process-aware proactive & reactive security

- Many exploitation scenarios require (prolonged) access to the target environment
- Know data sources vital to communication infrastructure recon and process comprehension
 - Be careful with public announcements and data exposure via trusted 3rd parties
 - Lock down or monitor access to critical data sources (in all!! their locations)
 - Monitor process behavior for anomalies

Inability to collect required information & interact with the process significantly limits attack scenarios achievable by threat actors





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